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RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
GROUP ART UNIT 2100

PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Hiroshi SONOBE

Group Art Unit: 2133

Serial No.: 09/557,088

Examiner: Matthew C. Dooley

Filed: April 21, 2000

For: SEMICONDUCTOR INSPECTION METHOD

## AMENDMENT UNDER 37 CFR \$1.116

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

In response to the Office Action mailed September 23, 2003, please amend the above-identified application as follows: